

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of: Confirmation Number: 7394

FUKIAGE et al.

Application No.: 10/702,048 Group Art Unit: 1792

Filed: November 6, 2003

Examiner: Tadayyon Eslami, Tabassom

Title: Method for Depositing Materials on a Substrate

AMENDMENT AFTER NON-FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Non-Final Office Action dated January 17, 2008, the due date for response to which has been extended to July 17, 2008 by the attached Petition for a Three Month Extension of Time and Fee, please amend the above-identified application as follows: